

Attorney's Docket No.: 4996 USA/W-C/W-C/JB1

Patent

1765

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Steven Verhaverbeke et al.

Examiner: Umez Bronini, L.I.

U.S. Serial No: 09/891,730

Art Unit: 1765

Filed: June 25, 2001

For: CLEANING METHOD AND SOLUTION
FOR CLEANING A WAFER IN A SINGLE
WAFER PROCESS

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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JUL 16 2003
GROUP 1700

RESPONSE TO ELECTION REQUIREMENT

Sir:

In response to the Election Requirement mailed June 9, 2003, applicant(s) hereby elects to prosecute Group I claims, claims 1-23, 38-100, 102, 104, 108-110 and 112 drawn to a method of processing a wafer. As such, applicant(s) elects to withdraw Group II claims 24-37, 101, 103, 105, 107 and 111 drawn to a cleaning solution; Group III claims 113-115 drawn to a rinse; Group IV claims 116-117 drawn to a method of rinsing a wafer; and Group V claims 118-121 drawn to a method of dissolving a gas without prejudice.

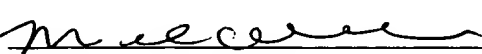
If there are any additional charges, please charge Deposit Account No. 02-2666.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

Date:

7/9/03


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APPLIED MATERIALS, INC.

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